Attorney Docket No. **10112971** ***PATENT***

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	**Ching-Wei LIN**	Filed:	**10/3/2003**
Appl. No.:	**10/678,908**	Examiner:	**EVERHART, CARIDAD**
Conf. No.:	**2225**	Art Unit:	**2891**

Title: **PROCESS FOR PASSIVATING POLYSILICON AND PROCESS FOR FABRICATING POLYSILICON THIN FILM TRANSISTOR**

Date: **December 22, 2006**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Please enter Amd 1/18/2007

AMENDMENT

Sir:

The Office Action mailed on **September 25, 2006** has been carefully considered. In response thereto, the Applicant respectfully requests entry of the amendments and consideration of the remarks as set forth herein below:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

All amendments and remarks made herein are without prejudice.